

Notice of References Cited	Application/Control No. 10/614,031	Applicant(s)/Patent Under Reexamination PAN ET AL.	
	Examiner Andre' C. Stevenson	Art Unit 2812	Page 1 of 1

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	B	US-5,219,769	06-1993	Yonehara et al.	438/105
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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